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SKJERVEN
MORRILL
MACPHERSON LLP

Docket No.: M-10693 US

June 26, 2001

1033 U.S. PTO
09/891693
06/26/01

Box Patent Application
Commissioner For Patents
Washington, D. C. 20231

Enclosed herewith for filing is a patent application, as follows:

Inventors: Steve Biellak, Stanley E. Stokowski and Mehdi Vaez-Iravan
Title: **SYSTEMS AND METHODS FOR A WAFER INSPECTION SYSTEM USING
MULTIPLE ANGLES AND MULTIPLE WAVELENGTH ILLUMINATION**

☒ Return Receipt Postcard
☒ This Transmittal Letter (in duplicate)
14 pages Specification (not including claims)
8 pages Claims
1 page Abstract
3 Sheets of Drawings
4 pages Declaration For Patent Application and Power of Attorney
1 page Recordation Form Cover Sheet (in duplicate)
2 pages Assignment
3 pages Information Disclosure Statement and PTO Form 1449 citing 21 references
☒ Copies of 21 Cited References submitted

CLAIMS AS FILED

For	Number Filed			Number Extra		Rate		Basic Fee
Total Claims	45	-20	=	25	x	\$ 18.00	=	\$ 450.00
Independent Claims	4	-3	=	1	x	\$80	=	\$ 80.00
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application								\$ _____
<input type="checkbox"/> Fee for Request for Extension of Time								\$ _____

Please make the following charges to Deposit Account 19-2386:

☒ Total fee for filing the patent application in the amount of \$ 1,240.00
☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account 19-2386.

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Respectfully submitted,



Rahul D. Engineer
Attorney for Applicants
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